

Title (en)
Polishing apparatus

Title (de)
Polivorrichtung

Title (fr)
Appareil de polissage

Publication
EP 2289668 A3 20140122 (EN)

Application
EP 10251498 A 20100826

Priority
JP 2009200690 A 20090831

Abstract (en)

[origin: EP2289668A2] The polishing apparatus (10) is capable of improving accuracy of polishing a work (W). The work (W) is pressed onto a polishing cloth (11), with an elastic sheet (36), by a pressing force generated by second pressing means (34) and applied to a carrier (28) and inner pressure of a first fluid chamber (38) generated by a fluid supplied thereto, so as to polish the work (W). The fluid, which has been downwardly supplied into the first fluid chamber (38), horizontally flows outward in the first fluid chamber (38), collides with a side wall of a concave part (23) of a board-shaped member (22) and flows upward, and then the fluid is discharged outside from a fluid outlet (44), thereby a fluid feeding member (31) follows movement of the elastic sheet (36) and maintains parallel thereto, and the fluid feeding member (31) is centered in the first fluid chamber (38).

IPC 8 full level
B24B 37/30 (2012.01); **H01L 21/304** (2006.01)

CPC (source: EP US)
B24B 37/30 (2013.01 - EP US)

Citation (search report)

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- [Y] EP 1582293 A2 20051005 - FUJIKOSHI MACHINERY CORP [JP]
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Designated contracting state (EPC)

AL AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HR HU IE IS IT LI LT LU LV MC MK MT NL NO PL PT RO SE SI SK SM TR

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BA ME RS

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